

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)	ATTY. DOCKET NO. 50395-124	SERIAL NO. 09/993,410
	APPLICANT Makoto KATAYAMA, et al.	
	FILING DATE November 21, 2001	GROUP 2872

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
<i>mtc</i>	62-183406	8/11/1987	Japan (w/ English Abstract)				

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	Kawai et al., "Variable optical attenuator based on PLC technology for gain control in WDM
	Society Convention, B-10-61, 1997)
<i>mtc</i>	Applied Physics, Vol. 60, No. 3, 1991, pp. 228-232.
<i>mtc</i>	"Silicon Micromaching High Technology", Science Forum, March 1992.
<i>mtc</i>	"Silicon Micromaching and Micro Mechatronics", Beifukan, June 1992.
EXAMINER <i>mtc</i>	DATE CONSIDERED <i>2 10 03</i>

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.